



03 28-23

PATENT  
Attorney Docket No.: 3521.174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of )

YUN WANG, ET AL. )

Serial No.: 10/390,504 )

Filed: March 13, 2003 )

Group Art Unit: 2823

Examiner: Brook Kebede

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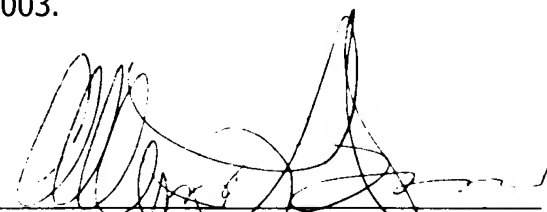
For: METHOD AND SYSTEM FOR LASER THERMAL PROCESSING OF  
SEMICONDUCTOR DEVICES

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**EXPRESS MAIL CERTIFICATE**

I hereby certify that this paper, and the listed enclosures, and fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated below and is addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 with the Express Mail Label No. EV268686239US on August 27, 2003.

  
\_\_\_\_\_  
Allston L. Jones, Attorney for Applicant

**TRANSMITTAL LETTER**

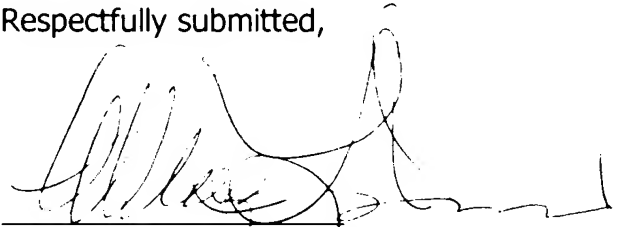
Transmitted herewith are the following documents:

1. Transmittal letter, in duplicate;

2. Information Disclosure Statement Under 37 C.F.R. 1.56 and 1.97;
3. PTO-1449;
4. Copy of 6 References as listed on 1449 form; and
5. Postcard.

If fees are required with the filing of these documents, the Commissioner is authorized to charge such fees to Deposit Account 16-1331.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Allston L. Jones', written over a horizontal line.

Allston L. Jones (Reg. No. 27,906)  
Attorney of Record

Date: August 27, 2003

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